

 INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>			Docket Number (optional) YOU102		Application No. 10/786,379		
			Applicants(s) Kim et al.				
			Filing Date February 25, 2004		Group Art Unit 1762		
			U.S. PATENT DOCUMENTS				
*Examiner Initial	REF	DOCUMENT NUMBER	DATE	NAME	CLASS/SUBCLASS	FILING DATE IF APPROPRIATE	
<i>ECC</i>		5,108,793	04/28/1992	van Ooij et al.	427/327		
<i>Ecc</i>		5,200,275	04/06/1993	van Ooij et al.	428/623		
<i>ECC</i>		5,292,549	03/08/1994	van Ooij et al.	427/156		
<i>ECC</i>		5,433,976	07/18/1995	van Ooij et al.	427/327		
<i>ECC</i>		5,487,792	01/30/1996	King et al.	136/256		
<i>ECC</i>		5,750,197	05/12/1998	van Ooij et al.	427/318		
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<i>ECC</i>		6,102,521	08/15/2000	Halko et al.	347/47		
<i>ECC</i>		6,183,815 B1	02/06/2001	Enick et al.	427/400		
<i>ECC</i>		6,461,682 B1	10/08/2002	Crotty et al.	427/387		
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/SUBCLASS	TRANSLATION	
						YES	NO
<i>Ecc</i>		WO 02/072283 A1	09/19/2002	PCT	BOSD/3/02		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER ERMA CAMERON			DATE CONSIDERED 11/17/05				
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<p style="text-align: center;">O P E R A T I O N S C E N T E R</p> <p style="text-align: center;">JAN 12 2005</p> <p style="text-align: center;">U. S. Patent and Trademark Office</p> <p style="text-align: center;">INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>		<p>Docket Number (optional) YOU102</p> <p>Application No. 10/786,379</p>
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
ECC	Azzaroni, O., M. Cipollone, M.E. Vela and R.C. Salvarezza, Protective properties of dodecanethiol layers on copper surface: The effect of chloride anions in aqueous environments, Langmuir, 17 (2001), pp. 1483-1487.	
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ECC	van Ooij, W.J. and T. Child, Protecting Metals with Silane Coupling Agents, Chemtech, 1998, pp. 26-35.	
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